

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application Serial No. . . . . 09/512,968  
Filing Date . . . . . February 24, 2000  
Inventor . . . . . David R. Hembree  
Assignee . . . . . Micron Technology, Inc.  
Group Art Unit . . . . . 2858  
Examiner . . . . . V. Nguyen  
Attorney's Docket No. . . . . MI22-1363  
Title: Electronic Device Workpiece Processing Apparatus and Method of Communicating  
Signals Within an Electronic Device Workpiece Processing Apparatus

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

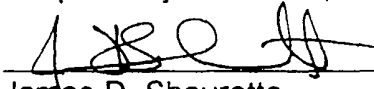
References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

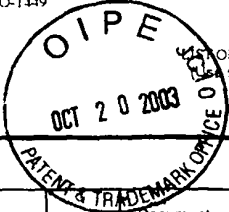
Dated: 1/28/02

Attorney:

Respectfully submitted,

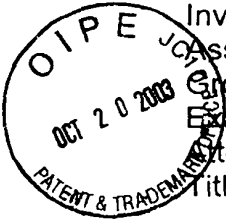
  
James D. Shaurette  
Reg. No. 39,833

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22.1363		SERIAL NO. 09/512 968	
					LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			
					APPLICANT David Hembree			
					FILING DATE February 24, 2000		GROUP 2858	
U.S. PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Name	Class	Subclasses	Filing Date if Appropriate		
	AA	5,612,574	3/18/97	Summerfelt et al.				
	AB	5,719,333	2/17/98	Hosoi et al.				
	AC	5,831,333	11/3/98	Malladi et al.				
	AD	5,919,548	7/6/99	Barron et al.				
	AE	5,551,283	9/3/96	Manaka et al.				
	AF	5,492,011	2/20/96	Amano et al.				
	AG							
	AH							
	AJ							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclasses	Translation	
							Yes	No
	AK							
	AL							
	AM							
	AO							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AP		"NTC and PTC Thermistors", <a href="http://www.thermodisc.com/ntcptc.html">http://www.thermodisc.com/ntcptc.html</a> , 1/7/98, 2 pages.					
	AR		"DI-5B35 Linearized 4-Wire RTD Input", <a href="http://www.dataq.com/di5b35.html">http://www.dataq.com/di5b35.html</a> , 1/7/98, 2 pages.					
	AS		"RTD", <a href="http://www.mhsensors.com/rtds.html">http://www.mhsensors.com/rtds.html</a> , 1/7/98, 3 pages.					
	AT		"Low Cost Thermal-Ribbon (TM) uses thin film RTD", <a href="http://www.minco.com/s17624nr.html">http://www.minco.com/s17624nr.html</a> , 1/7/98, 1 page.					
	AU		"Silicon Processing for the VLSI Era", Volume 1 - Process Technology, Second Edition, S. Wolf et al., 2000, pps 22-25 and pps. 841-845.					
EXAMINER					DATE CONSIDERED			
*EXAMINER. Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

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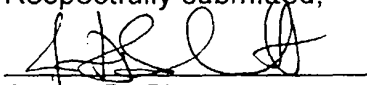


SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

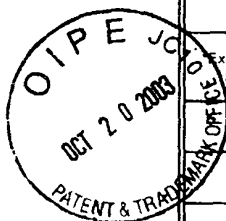
The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Dated: 3/25/03

Respectfully submitted,  
Attorney:   
James D. Shaurette  
Reg. No. 39,833

EV085431126

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1363		SERIAL NO. 09/512 958	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology, Inc.			
				FILING DATE February 24, 2000		PRIORITY GROUP 2858	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,912,500	3/1990	Jaeger et al.	361	700	
	AB	5,436,494	7/1995	Mosleh	257	467	
	AC	5,969,639	10/1999	Lauf et al.	340	870 17	
	AD						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AE						
	AF						
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	AI						
	AJ						
	AK						
	AL						
EXAMINER				DATE CONSIDERED			
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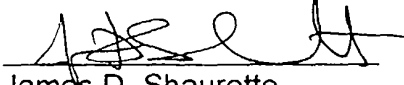
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References -- See Attached Form PTO-1449


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Dated: 5/6/03

Respectfully submitted,  
Attorney:   
James D. Shaurette  
Reg. No. 39,833

**E✓085425944**

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO MI22-1363		SERIAL NO 09/512 968	
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology Inc		FILING DATE February 24 2000	
				PRIORITY GROUP 2853			
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA 4,355,463	10/26/1982	Burns				
	AB						
	AC						
	AD						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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	AG						
	AH		E 1085425944				
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<u>EXAMINER</u>				<u>DATE CONSIDERED</u>			
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

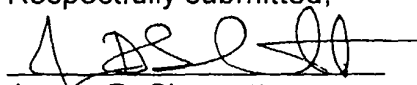
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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

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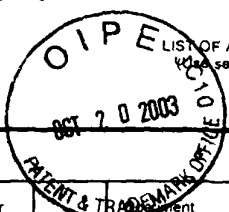
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Dated: 6/12/03

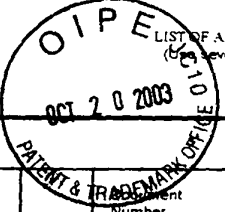
Respectfully submitted,  
  
Attorney: James D. Shaurette  
Reg. No. 39,833

EV 317135597

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				APPLICANT Micron Technology, Inc.  FILING DATE February 24, 2000			
U.S. PATENT DOCUMENTS							
*Examiner Initial	Assessment Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA 3,710,251	1/9/1973	Hagge et al.				
	AB						
	AC						
	AD						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AE		E/317135597				
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Form PTO-1 449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M22-1363		SERIAL NO 09/512.968	
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AS		"RTD"; <a href="http://www.mbsensors.com/rtds.html">http://www.mbsensors.com/rtds.html</a> ; 1/7/98; 3 pages.					
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AU		"Silicon Processing for the VLSI Era"; Volume 1 - Process Technology; Second Edition; S. Wolf et al.; 2000; pps 22-25 and pps. 841-845.					
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